



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Nguyen

Attorney Docket No.: LAM1P155D1

Application No.: 10/802,647

Examiner: Michail Kornakov

Filed: March 16, 2004

Group: 1746

Title: METHOD AND APPARATUS FOR  
REDUCING HE BACKSIDE FAULTS DURING  
WAFER PROCESSING

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on December 22, 2004 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: \_\_\_\_\_

Agnes Spence

**AMENDMENT AFTER ALLOWANCE, BEFORE PAYMENT OF ISSUE FEE  
PURSUANT to 37 C.F.R. §1.312 (a)**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Kindly amend the above-identified application as follows:

In the Examiner's Amendment, the Examiner changed the first paragraph of the above-referenced application. While this was generally acceptable, it should be noted that a typographical error was found. Therefore please amend the Examiner's amendment first paragraph as follows:

"The present application is divisional application of co-pending U.S. Application No. 09/747,703, filed December 21, 2000 now U.S. Patent No. 6,733,591[[5]]4 which is incorporated by reference herein in it's entirety."

Applicant hereby respectfully requests that on recommendation of the Examiner and approval by the Director that this amendment is entered. If there are any questions with regards to this matter, please do not hesitate to contact at us at the number below.

Respectfully submitted,  
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